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Docket No.: E20020390

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In re Application of: Wai Biu Cheng

Title: High Fidelity Low-Order Modeling For Multi-Staged Separation Processes Based
Upon The Compartmental Approach

Serial No.: 10/694113

Filed: October 27, 2003

Applicant: ABB Inc.

RESPONSE TO NOTICE REGARDING DRAWINGS

This letter and the accompanying Replacement Sheet are being filed in response to the Notice Regarding Drawings mailed on 10 May 2006 for the subject application. There are no fees due at this time.

7/7/06
Date

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CERTIFICATE OF MAILING (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

July 7, 2006
Date

Debra Rietze
(Typed or printed name of person mailing document)

Debra Rietze
(Signature of person mailing document)